Application/Control No.	Applicant(s)/Patent under Reexamination	
10/500,758	HAEB-UMBACH ET AL.	
Examiner	Art Unit	
Corey P. Chau	2615	

	SEARCHED			
Class	Subclass	Date	Examiner	
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INTERFERENCE SEARCHED			
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
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